

Notice of References Cited	Application/Control No. 10/563,678		Applicant(s)/Patent Under Reexamination NAKAMURA ET AL.	
	Examiner KIM CHU		Art Unit 2627	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,102,972	09-2006	Lee et al.	369/53.17
*	B	US-6,549,494	04-2003	Kobayashi, Tadashi	369/47.1
*	C	US-6,418,111	07-2002	Takemura et al.	369/275.3
*	D	US-6,683,835	01-2004	Ko et al.	369/53.21
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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